

Online Measurement of Bunch Lengths and Fill-pattern in the PLS-II Storage Ring Using a Fast Photodiode

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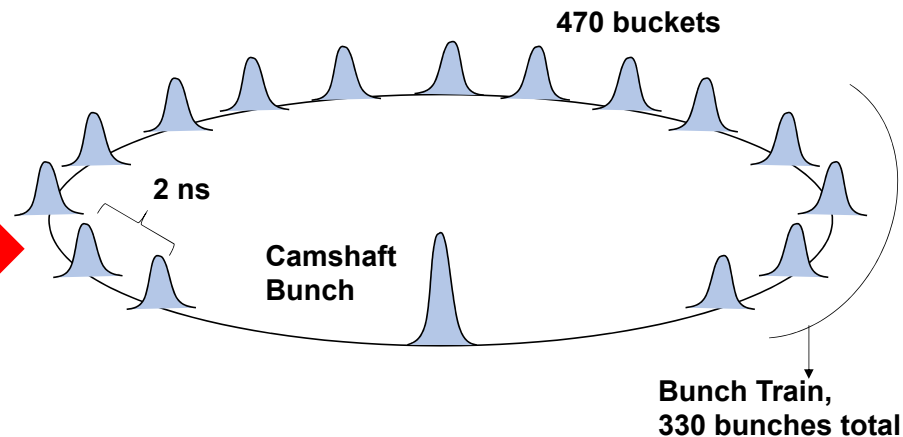
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and J. Hwang (HZB)**

Jun. 16, 2022

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Pohang Accelerator Laboratory

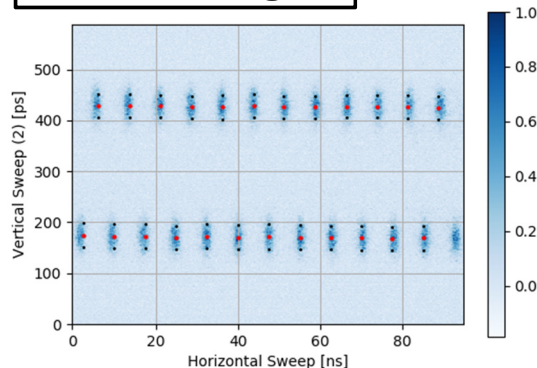


PLS-II Parameter	Value	Unit
Beam Energy	3	GeV
Beam Current	400	mA
Circumference	281.82	m
RF Frequency	499.97	MHz
RMS Bunch Length	6.4	mm

- PLS-II operates a hybrid filling pattern to serve time-resolving experiments.
- Online bunch length and filling pattern monitoring is requested by users.

Longitudinal Beam Diagnostics

Bunch Length



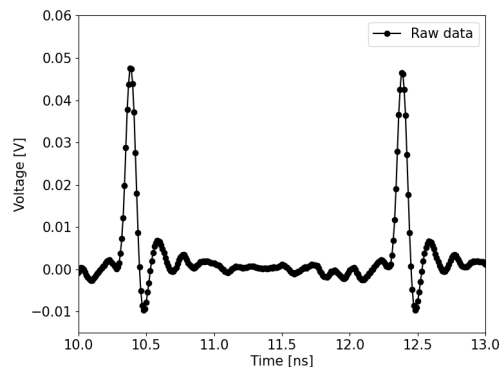
Streak Camera

- High temporal resolution ($< \text{RMS } 1 \text{ ps}$)
- Slow acquisition rate
- Incompatible for turn-by-turn measurements

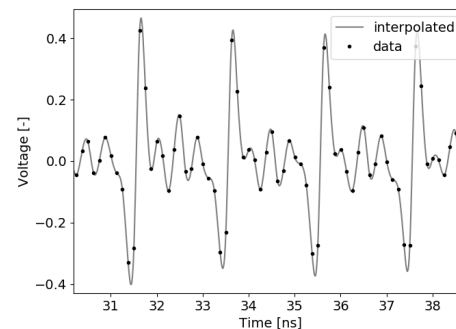
Bunch Length + Fill-Pattern

Fast Photodiode

- Intermediate resolution ($\sim 2 \text{ ps}$)
- Bunch length and fill-pattern real time measurement



Fill-Pattern



BPM pick-up

- Fill-pattern monitoring
- Limited bandwidth
- Moderate accuracy
- Non-linear behavior causes intolerable error

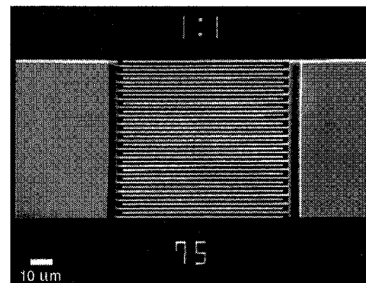
MSM Photodiode

- Metal-Semiconductor-Metal Photodiode
 - Metal-semiconductor Junction
 - Schottky diode's potential barrier is ruled by the metal and silicon work functions.

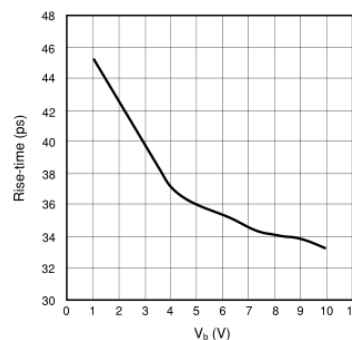
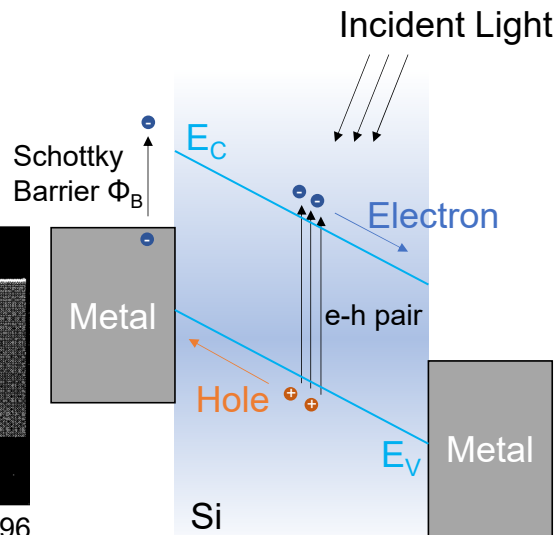
MSM photodiode has fast response.

- Hamamatsu G4176-03
(GaAs MSM photodiode)

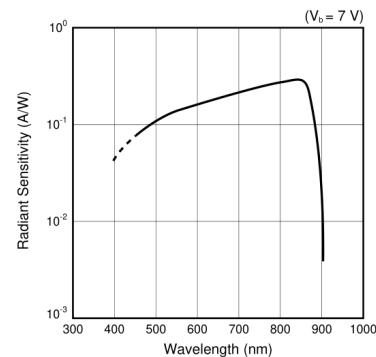
- Rise time ~ 35 ps @ 7 V bias
- Active area : 200 μm^2
- Dark current : 100 pA @ $T_a = 25^\circ\text{C}$



P. R. Berger, 1996

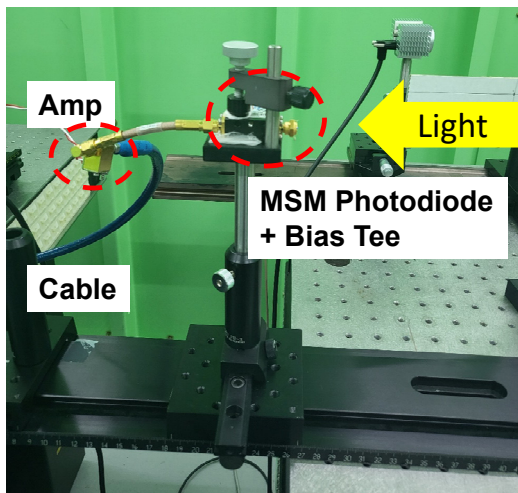
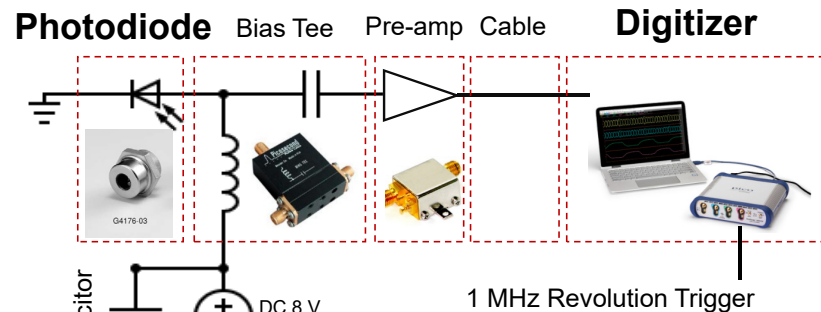


Rise time vs. Applied Voltage

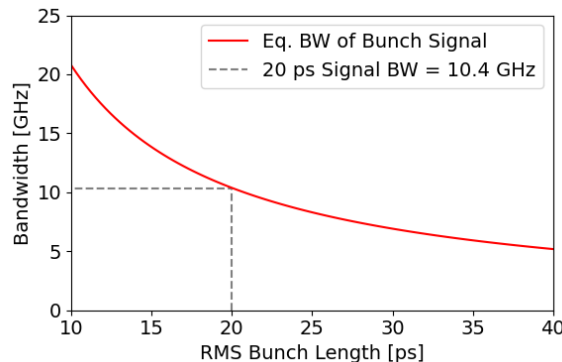


Spectral Response

Experimental Setup



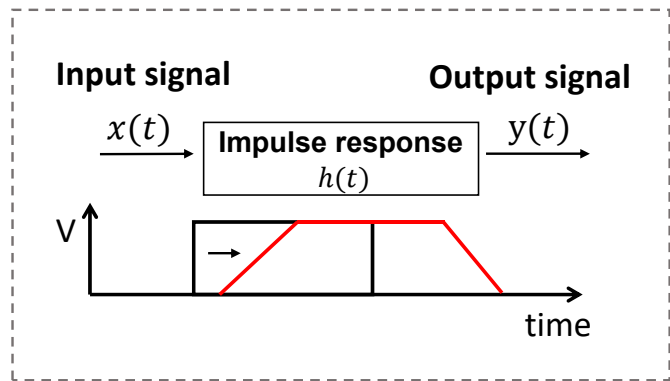
- Fill-pattern and bunch lengths are obtained by direct measurements of the synchrotron radiation (visible light).
- The system consists of wide-bandwidth electronics for short bunch length measurements.



Component	Bandwidth
Photodiode	10 GHz
Bias Tee	26 GHz
Amplifier	14 GHz
Cable	26.5 GHz
Digitizer	16 GHz

→ **Signal processing method is mandatory for precise reconstruction.**

Analytic Gaussian Deconvolution



$$y(t) = x(t) * h(t) = \int x(\tau) h(t - \tau) d\tau$$

↑

System response function

$$: h_{sys} = h_{PD} * h_{bias\ T} * h_{amp} * \dots$$

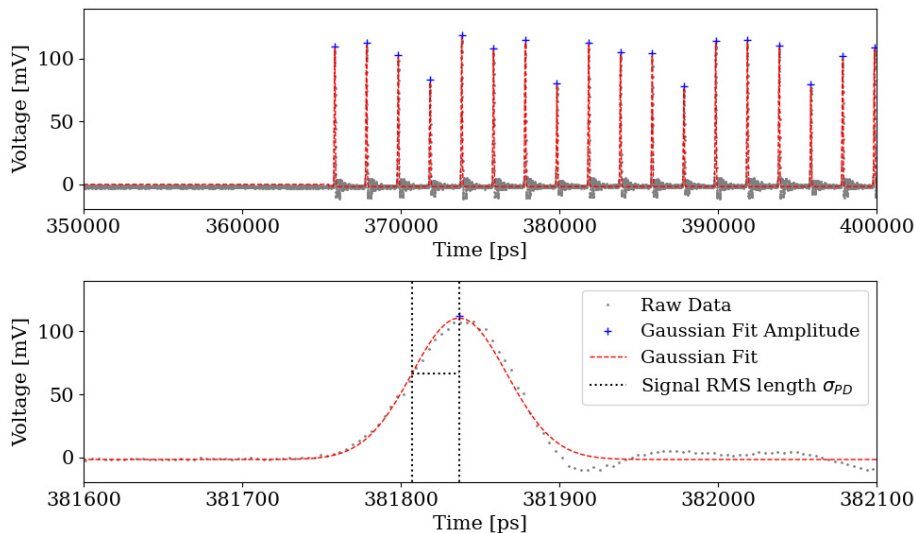
$$\sigma_y^2 = \sigma_x^2 + \sigma_h^2$$

- The input signal is reconstructed by analytically deconvolving the output signal with a Gaussian kernel.
- The system's impulse response is used as a deconvolution kernel.

Analytic Gaussian Deconvolution	
Pros	• Practical • Fast
Cons	• Inaccuracy (Error with Gaussian assumption)

Analytic Gaussian Deconvolution

Fill Pattern Measurement

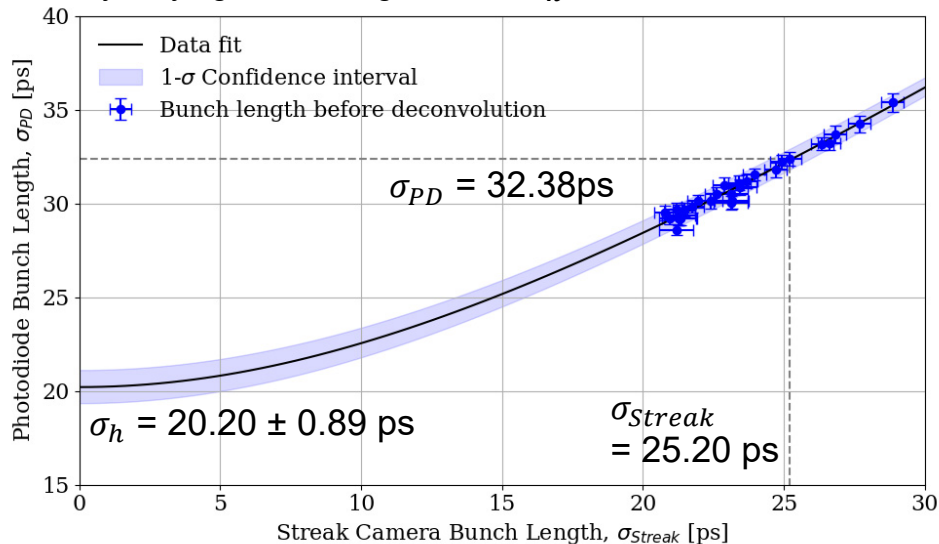


- Measurement limit of beam current = 6 μA
- Resolution (SNR = 1) = 3 μA

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Bunch Length Calibration

- The photodiode is calibrated using a streak camera by varying bunch length to find σ_h .

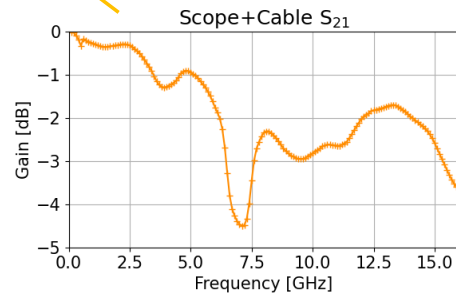
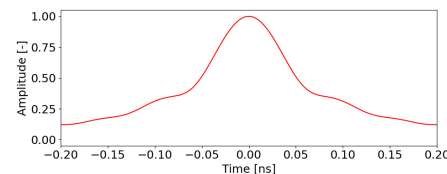
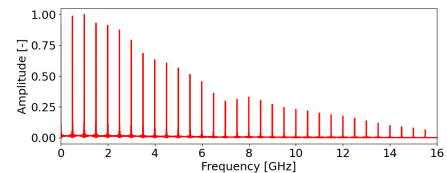
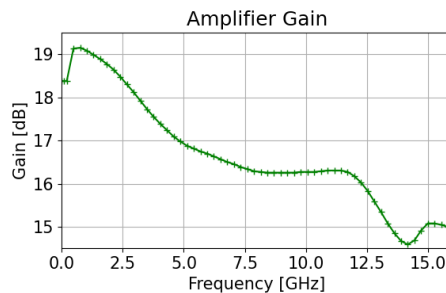
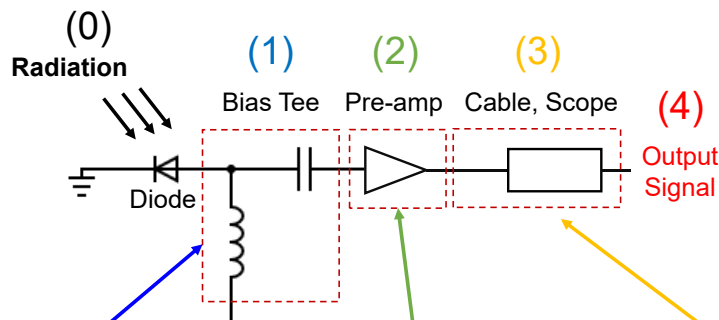
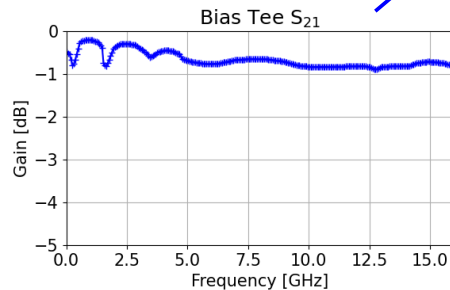
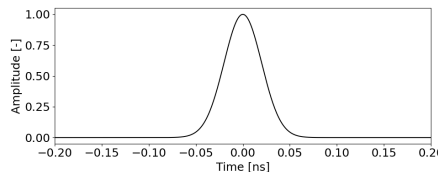
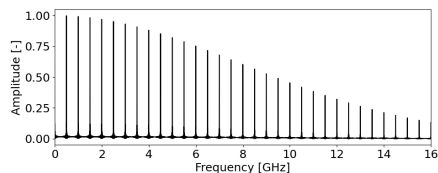


$$\sigma_{decon.} = \sqrt{\sigma_{PD}^2 - \sigma_h^2} = \sqrt{(32.38 \text{ ps})^2 - (20.20 \text{ ps})^2}$$

$$= 25.31 \text{ ps}$$

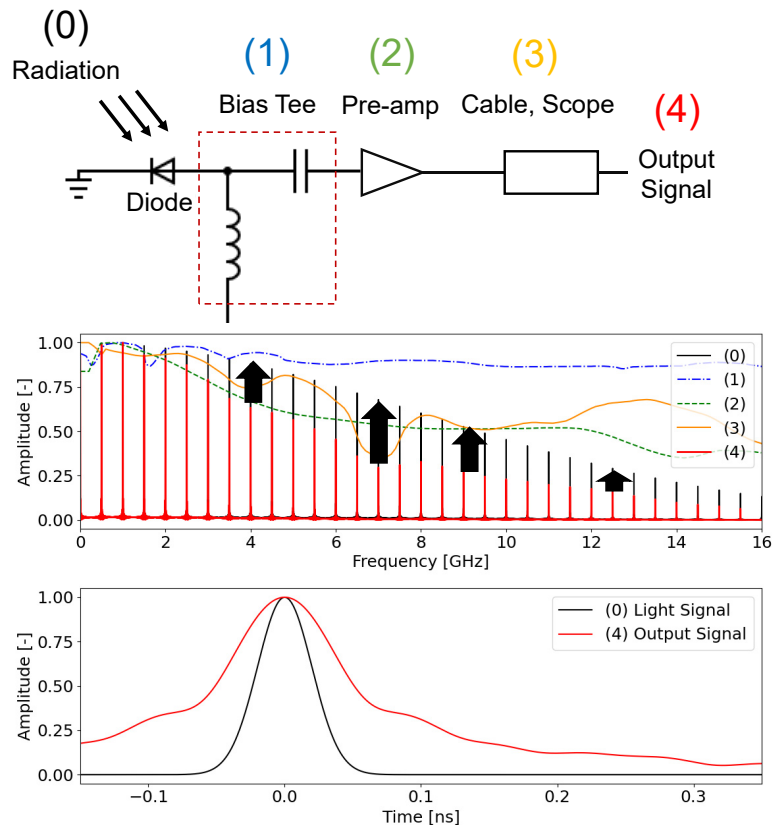
$$\sigma_{Streak} = 25.20 \text{ ps}$$

Numerical Compensation



→ The measured signal is distorted strongly by the frequency response of analog components.

Numerical Compensation



- The beam shape is retrieved by applying the measured frequency response of each component to the numerical compensation method.
- Frequency response of each device has to be measured precisely at least digitizer bandwidth.

Numerical Compensation

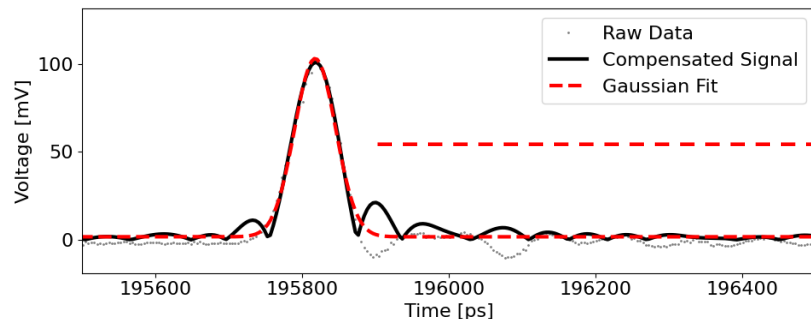
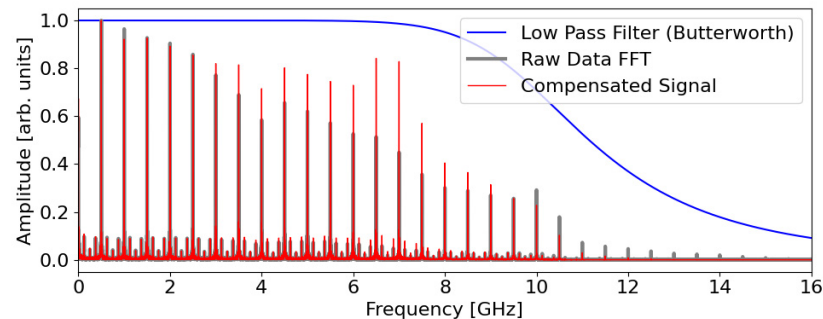
Pros

- Still fast
- Accurate

Cons

- Frequency response can be changed according to circumstance. (ex. Temp, Connection ...)

Numerical Compensation



- Low pass filter is used to eliminate high-frequency noise.
- Obtain the charge and length of each bunch by inverse FFT of the signal recovered in the spectral domain.
- The diode response is subtracted in the same way as Gaussian deconvolution.

Fit Model

$$Ae^{\left(\frac{-(t-\mu)^2}{2\sigma_t^2}\right)} + G \longrightarrow G : \text{Ground level}$$

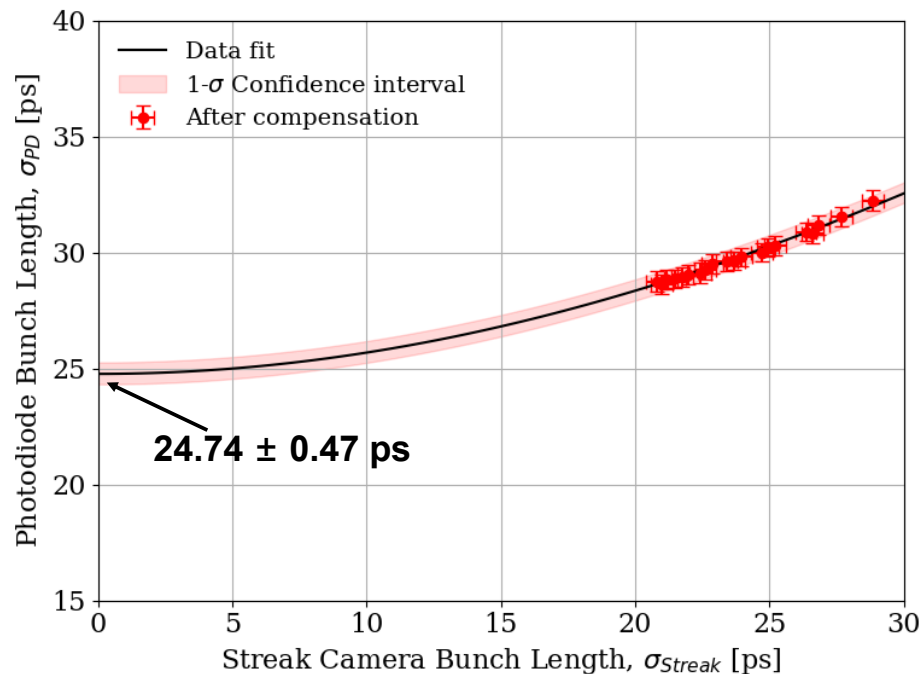
A : Bunch Charge
(Fill-pattern)

μ : Central Position

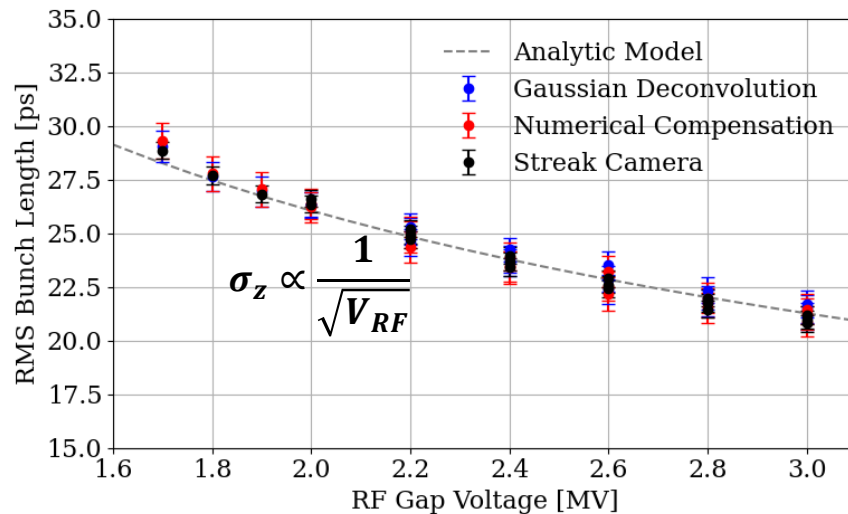
σ_t : Bunch Length $\rightarrow \sigma_{numer.} = \sqrt{\sigma_t^2 - \sigma_{calib}^2} + c$

Bunch Lengthening Experiment

Calibration Result

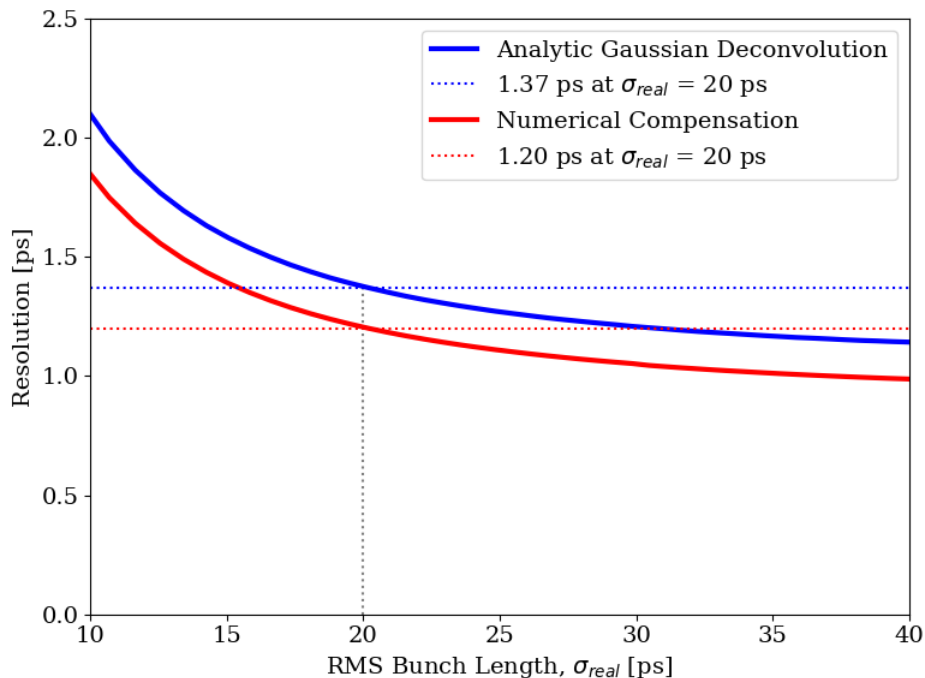


Bunch Lengthening Experimental Result



- The bunch length changes by varying field gradients in RF cavities and its behavior agrees quantitatively well with the theory.

Statically Estimated Resolution



- **Systematic error** of the system depends on the absolute bunch length due to a finite bandwidth.
- It is mainly determined by fitting errors and trigger jitter.
- The numerical compensation method reduces the systematic error since it enables a precise retrieval of the beam signal.

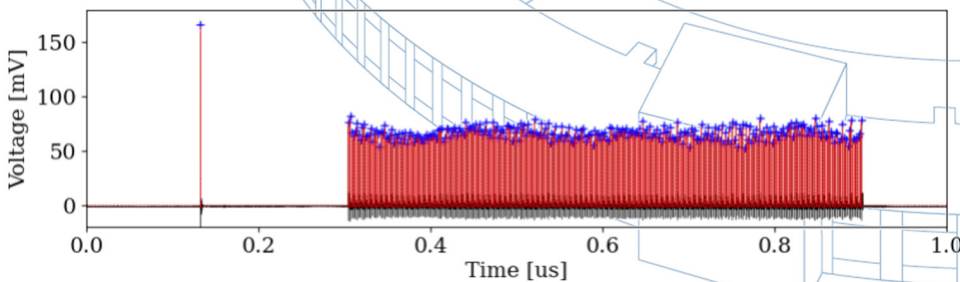
Summary

- We have experimentally demonstrated a compact monitor that enables **filling pattern** ($\sim 3 \mu\text{A}$ resolution) and **bunch length** ($\sim 1 \text{ ps}$ resolution) monitoring with visible light at the PLS-II storage ring.
- Analytical Gaussian deconvolution and numerical compensation were investigated to improve measurement accuracy.
 - Numerical compensation can achieve better resolution.
- Online Turn-by-turn/Bunch-by-bunch measurements are under contemplation as a future upgrade project.

Thank you for your attention

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PLS-II



BESSY-II

